IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

priority Application Serial No10/271	,888
Confirmation Nounkn	own
priority Filing Date	2002
InventorF. Gonz	alez
AssigneeMicron Technology,	Inc.
priority Group Art Unit	2818
priority Examiner	² . Le
Attorney's Docket NoMI22-2	2383
Customer No	1567
Title: Methods Of Forming Semiconductor Constructions	

PRELIMINARY AMENDMENT

To:

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

From:

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AMENDMENTS